

AF/IFW

RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE REQUESTED EXAMINING GROUP 1734

PATENT Customer No. 22,852 Attorney Docket No. 04173.0438

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Tetsuya KUROSAWA) Group Art Unit: 1734
Application No.: 10/665,206) Examiner: Osele, Mark A.
Filed: September 22, 2003))
For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND MANUFACTURING APPARATUS OF SEMICONDUCTOR DEVICE))))

Mail Stop AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action mailed February 15, 2005, the period for response to which extends through May 16, 2005 (May 15th being a Sunday), and pursuant to 37 C.F.R. § 1.116, Applicant proposes that this application be amended as follows:

Amendments to the Specification are set forth beginning on page 2 of this paper.

Amendments to the Drawings are made in the attached replacement sheets and are discussed in the Remarks section of this paper.

Remarks begin on page 9 of this paper.

Attachment to this Amendment: three (3) sheets of drawings, each labeled "Replacement Sheet," containing amended FIGS. 18A, 18B, 18C, 18D, 19, and 20.